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IN THE UNITED STATES  
PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

Applicant: Noorbakhsh, et al. Case: 4150D1/ETCH/DRIE/JB1  
Serial No.: Not yet assigned Filed: Herewith  
Examiner: Not yet assigned Group Art Unit: Not yet  
assigned  
Title: TEMPERATURE CONTROLLED SEMICONDUCTOR PROCESSING  
CHAMBER LINER

ASSISTANT COMMISSIONER FOR PATENTS  
Washington, DC 20231

S I R:

Disclosure Statement Under 37 C.F.R. 1.56 and 1.98

The above-referenced application is a divisional of co-pending United States Patent Application Serial No. 09/519,719, filed March 7, 2000. Pursuant to 37 C.F.R. 1.56, the documents (one copy enclosed) listed on Form PTO-1449, submitted herewith, are disclosed. Under Rule 37 C.F.R. 1.98(d), the Applicants submit that no copies of references are required for any reference previously cited in Application Serial No. 09/519,719, in compliance with 37 C.F.R. 1.98(a).

Respectfully submitted,

1/16/02  
Date

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